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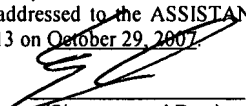
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): Hoon Kim et al.  
SERIAL NO.: 10/779,446 EXAMINER: Shi K. Li  
DATE FILED: February 13, 2004 ART UNIT: 2613  
FOR: PASSIVE OPTICAL NETWORK USING ERROR CORRECTION  
CODE

CERTIFICATE OF MAILING UNDER 37 CFR §1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the ASSISTANT COMMISSIONER FOR PATENTS, P.O. BOX 1450 ALEXANDRIA, VA 22313 on October 29, 2007.

Steve S. Cha, Reg. No.: 44,069  
(Name of depositor)

  
(Signature and Date)

Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, Virginia 22313

Sir:

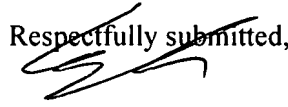
INFORMATION DISCLOSURE STATEMENT

In accordance with Applicant's and Applicant's representatives' Duty of Disclosure under 37 CFR § 1.56, and pursuant to 37 CFR §1.97(d) and MPEP 717.05(b), Applicant(s) submit herewith documentary information for consideration by the Examiner. Information herein cited is only set forth in fulfillment of Applicant's duty of candor in disclosing all information brought to his attention, and is not an admission that it can be used adversely. The publications forwarded herewith are listed on the enclosed Form PTO-1449. Applicant(s) request that the Examiner, upon reviewing the enclosed materials, initial the enclosed form and return a copy thereof in accordance with the instructions on the form.

Applicant further note that each item of information contained in the enclosed Form was first cited from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the statement.

Enclosed please find copies of 4 Foreign References listed on the attached Form PTO-1449.

Respectfully submitted,

  
Steve S. Cha  
Attorney for Applicants  
Registration No. 44,069

CHA & REITER, LLC  
210 Route 4 East #103  
Paramus, New Jersey 07652  
(201) 226-9245  
Date: October 29, 2007